

Notice of References Cited	Application/Control No. 10/802,717	Applicant(s)/Patent Under Reexamination SAITO ET AL.	
	Examiner Nicole Blan	Art Unit 1709	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,028,135	06-1977	Vig et al.	134/1
*	B	US-4,442,852	04-1984	Lord, C. Dennis	134/135
*	C	US-5,505,785	04-1996	Ferrell, Gary W.	134/1
*	D	US-4,624,690	11-1986	Byrnes, John	55/385.1
*	E	US-3,900,339	08-1975	Filipin et al.	134/22.1
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Products: Microarray Instruments." TeleChem International, Inc. 24 December 2002. < http://web.archive.org/web/20021224172955/http://arrayit.com/Products/Microarray/PPCK80/ppck80.html >. * Note this was obtained using the WayBack Machine.
	V	Jackson, David P. "Centrifugal Shear Carbon Dioxide Cleaning." Adv. Mater. Process. 1995. < http://www.p2pays.org/ref/02/01015.pdf >
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.